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Type-II BiVO₄/Ni₃(hexahydroxytriphenylene)₂ heterojunction photoanodes for effective photoelectrochemical reaction†

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Semiconducting M₃(hexahydroxytriphenylene)₂ (M = Ni, Co, Cu; hexahydroxytriphenylene (HHTP)) was uniformly coated onto BiVO₄ thin films via a facile solvothermal process, and the photoelectrochemical performance of the BiVO₄/M₃(HHTP)₂ photoanodes was investigated. All three BiVO₄/M₃(HHTP)₂ photoanodes exhibited higher photocurrent densities than pristine BiVO₄. This can be attributed to the formation of type-II heterojunctions, as confirmed by ultraviolet photoelectron spectroscopy (UPS) and ultraviolet-visible spectroscopy. BiVO₄/Ni₃(HHTP)₂ exhibited the highest photocurrent density of 4.66 mA cm⁻² at 1.23 V vs. a reversible hydrogen electrode (RHE), an approximately 3.2-fold increase from that of pristine BiVO₄. The results suggest that the type of metal ion in M₃(HHTP)₂ affects the electrical conductivity, which significantly influences the charge transport kinetics in the photoelectrochemical reactions of BiVO₄. The mechanism underlying the enhanced photoelectrochemical reaction was also investigated.

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Introduction

Hydrogen fuel is a sustainable energy source that can be used as an alternative to fossil fuels. Photoelectrochemical water splitting is an environment-friendly method to produce hydrogen from water by utilizing solar energy. This method has drawn significant attention owing to its potential for negligible greenhouse gas emissions. Among the diverse metal oxide photoanodes used for photoelectrochemical water splitting,^{1,2} BiVO₄ is a promising candidate because of its 2.4–2.5 eV bandgap, which is advantageous for absorbing visible light. However, its sluggish charge transfer kinetics and short hole diffusion length hamper charge transport and separation.³ Accordingly, various methods have been considered to improve the photoelectrochemical performance of BiVO₄, including surface area expansion, doping, and heterostructure design.^{4–8}

The rational design of a type-II heterojunction with another semiconductor is a promising strategy to enhance the photoelectrochemical performance of BiVO₄.^{9–12} A type-II heterojunction established between two different semiconductors facilitates the separation of photogenerated charge carriers, preventing charge recombination losses. Because a staggered band alignment is required, it is important to consider both the

energy bandgap and band positions of the two semiconductors. The light absorption rate is determined by the energy bandgap, oxygen evolution reaction (OER), or hydrogen evolution reaction (HER) based on the band positions. Various heterostructures with staggered band alignments have been proposed to compensate for the sluggish OER, such as WO₃/BiVO₄,⁵ TiO₂/BiVO₄,⁶ and BiVO₄/MoS₂,⁷ however, further enhancement of the photoelectrochemical performance is required.

In recent years, heterojunctions between metal–organic frameworks (MOFs) and BiVO₄, such as BiVO₄/CoNi-MOF,¹³ BiVO₄/MIL-53(Fe),¹⁴ and BiVO₄/MIL-101(Fe),¹⁵ have been investigated to improve the photoelectrochemical performance. The design and application of MOFs for photoelectrochemical reactions have been widely investigated because MOFs provide advantages such as extremely high surface area, tunable porosity, and compositional diversity and exhibit semiconducting properties. Semiconducting MOFs with suitable band structures and high electrical conductivity are promising platforms for designing photoanodes with staggered band alignments.¹⁶ Among various MOFs, M₃(HHTP)₂ (M = Ni, Co, and Cu; 2,3,6,7,10,11-hexahydroxytriphenylene (HHTP)) has shown good electrical conduction through π–π stacked pathways as well as suitable bandgaps for water splitting.¹⁷ Because of their conductive nature, M₃(HHTP)₂ photoanodes are expected to exhibit high photoelectrochemical performance. However, to the best of our knowledge, the heterojunction between BiVO₄ and M₃(HHTP)₂ for photoelectrochemical reactions has yet to be investigated.

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Herein, we report the highly efficient photoelectrochemical reaction of a $\text{BiVO}_4/\text{M}_3(\text{HHTP})_2$ photoanode. The BiVO_4 film was coated onto fluorine doped tin oxide (FTO)/glass substrates by electrodeposition, then the $\text{M}_3(\text{HHTP})_2$ was coated onto the BiVO_4 film *via* a solvothermal reaction. All $\text{BiVO}_4/\text{M}_3(\text{HHTP})_2$ photoanodes showed significantly higher photocurrent densities than pristine BiVO_4 , which is attributed to the type-II heterojunctions established between BiVO_4 and $\text{M}_3(\text{HHTP})_2$. Notably, $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ exhibited the highest photocurrent density of 4.66 mA cm^{-2} , which is a 3.2-fold increase in efficiency from that of pristine BiVO_4 . This study reveals that the electrical conductivity of $\text{M}_3(\text{HHTP})_2$ is dependent on the type of metal ions, which play a key role in the charge transport for photoelectrochemical reactions. The main purpose of this study is to determine the key parameters affecting the OER in $\text{BiVO}_4/\text{M}_3(\text{HHTP})_2$ heterostructure photoanodes and to understand the mechanism underlying the enhanced photoelectrochemical reaction.

Experimental

Sample preparation

BiVO_4 nanoparticles were coated onto FTO/glass substrates by a modified electrodeposition method.^{18,19} The typical synthesis process includes an FTO/glass substrate, platinum (Pt) mesh, and Ag/AgCl/saturated NaCl as the working, counter, and reference electrodes, respectively. The precursor solution for BiVO_4 electrodeposition was prepared as follows. 1.141 g of vanadium oxide sulfate hydrate ($\text{VOSO}_4 \cdot x\text{H}_2\text{O}$, 99.9%, Alfa Aesar), and 0.97014 g of bismuth nitrate pentahydrate ($\text{Bi}(\text{NO}_3)_3 \cdot 5\text{H}_2\text{O}$, 98.0%, Junsei) were dissolved in an aqueous

HNO_3 solution (100 mL, 1:9 (v/v) mixture of 60% HNO_3 and deionized (DI) water) under magnetic stirring to form a clear solution. A stabilizer solution was prepared by dissolving 32.812 g of sodium acetate in 100 mL of DI water, and then added to the Bi/V ion solution. The pH of the solution for electrodeposition was adjusted to 4.7. This mildly acidic pH solution is required for electrodeposition because no film can be deposited at pH values, in which Bi ions are soluble ($\text{pH} < 2$). Excessive precipitates hinder the film deposition at $\text{pH} > 5$.¹⁹ Electrodeposition was performed at 0.8 V for 1 h at room temperature. The prepared substrates were rinsed with DI water and annealed at $550 \text{ }^\circ\text{C}$ for 3 h.

$\text{Ni}_3(\text{HHTP})_2$ was coated onto the BiVO_4 film *via* a solvothermal reaction. 2.5 mmol of nickel acetate tetrahydrate ($\text{Ni}(\text{OCOCH}_3)_2 \cdot 4\text{H}_2\text{O}$, 98.0%, Merck) was dissolved in 20 mL of DI water, and 1.25 mmol of 2,3,6,7,10,11-hexahydroxytriphenylene (HHTP, 95.0%, Acros Organics) was dissolved in 10 mL methanol. The two solutions were mixed and homogenized by stirring. Then, the mixed solution was placed in a Teflon-lined stainless-steel autoclave with a $\text{BiVO}_4/\text{FTO}/\text{glass}$ substrate immersed in it. The sealed autoclave was heated to $85 \text{ }^\circ\text{C}$ for 3.5 h. The substrates were rinsed with DI water thrice.

Results & discussion

A schematic of the procedure for preparing the $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ heterojunction on an FTO/glass substrate is shown in Fig. 1. The BiVO_4 thin film was anodically electrodeposited onto the FTO/glass substrate using an aqueous solution containing $\text{Bi}(\text{III})$ ions and $\text{V}(\text{IV})$ ions. This was followed by heat treatment at $500 \text{ }^\circ\text{C}$ for 2 h to achieve crystalline BiVO_4 . The

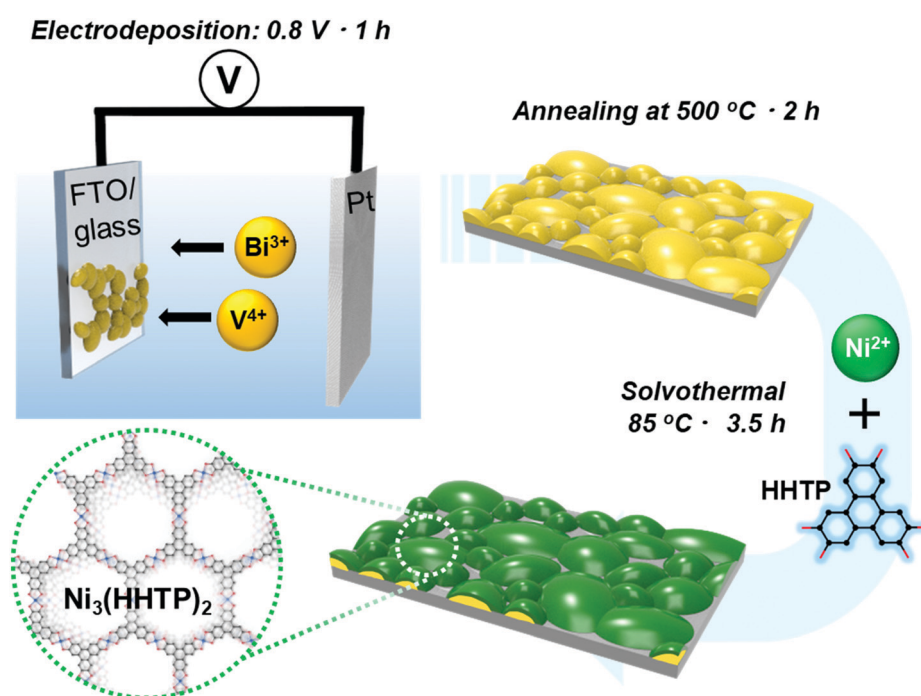


Fig. 1 Schematic diagram of the synthesis process for the $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ heterostructure on FTO/glass substrate.



BiVO₄ thin film appeared as bright yellow (Fig. S1a, ESI[†]). The X-ray diffraction (XRD) pattern showed that the crystalline peaks are monoclinic BiVO₄ (Fig. S1b, ESI[†]). The scanning electron microscopy (SEM) images of the BiVO₄ thin film (Fig. S2a and b, ESI[†]) revealed that the film consists of large grains ranging from 100 to 500 nm with a thickness of 250–300 nm. The transmission electron microscopy (TEM) image and selected area electron diffraction (SAED) patterns of BiVO₄ confirmed its crystalline structure. The inter-planar spacing in the lattice fringes was analyzed to be $d_{(040)} = 2.90 \pm 0.1$ Å (Fig. S2c, ESI[†]), which corresponds to the monoclinic BiVO₄. Elemental mapping further confirmed that the Bi and V components were uniformly distributed along the whole grains (Fig. S2(d1)–S4, ESI[†]).

Ni₃(HHTP)₂ was coated onto the surface of BiVO₄ by a solvothermal reaction at 85 °C for 3.5 h (Fig. 2a and b). The solvothermal reaction enables the conformal, well-attached, and uniform growth of Ni₃(HHTP)₂ on the BiVO₄ surface. This is desirable in photoelectrochemical reactions because the strong adhesion between the BiVO₄ and MOF ensures high stability. The color of the photoanode changed from bright yellow to dark green after the solvothermal growth of Ni₃(HHTP)₂ on the BiVO₄ thin film (Fig. 2c). Close examination of the high-resolution TEM (Fig. 2d) and elemental mapping (Fig. 2e1–6) confirmed that the Ni₃(HHTP)₂ layer (150–200 nm

thickness) was uniformly coated onto the BiVO₄ surface. Owing to the XRD detection limit and the negligible number of MOFs, Ni₃(HHTP)₂ peaks were not observed in the XRD patterns (Fig. S3a, ESI[†]). To prepare a sufficient amount of Ni₃(HHTP)₂, the solvothermal reaction time was increased to 6 h. The detected peaks of MOF at $2\theta = 5\text{--}20^\circ$ were in agreement with those observed in the simulated XRD patterns of Ni₃(HHTP)₂ (Fig. S3b, ESI[†]), confirming the formation of Ni₃(HHTP)₂ *via* the solvothermal reaction.^{20–22} Furthermore, the atomic composition of the BiVO₄/M₃(HHTP)₂ (M = Ni, Co, Cu) was analyzed by XPS (Fig. S4–S6, ESI[†]), and the existence of all the elements was confirmed by peak analysis. To examine the influence of the solvothermal reaction time on the growth of Ni₃(HHTP)₂ on the BiVO₄ surface, the reaction time was controlled up to 1 h and 6 h. As the MOF precursor solution containing nickel ions and HHTP ligands induced rapid nucleation and growth at the initial stage, the morphology of Ni₃(HHTP)₂ after the 1 h and 3.5 h solvothermal reactions appeared to be similar (Fig. S7a, b, ESI[†] and Fig. 2a, b). However, when the solvothermal reaction time increased to 6 h, a thick Ni₃(HHTP)₂ layer (4–5 μm) unevenly covered the BiVO₄ film (Fig. S7c and d, ESI[†]). An excessively thick Ni₃(HHTP)₂ layer will affect the charge transfer within the Ni₃(HHTP)₂, which would deteriorate photoelectrochemical reaction. Hence, the thickness of Ni₃(HHTP)₂ should be optimized by controlling the solvothermal reaction time.

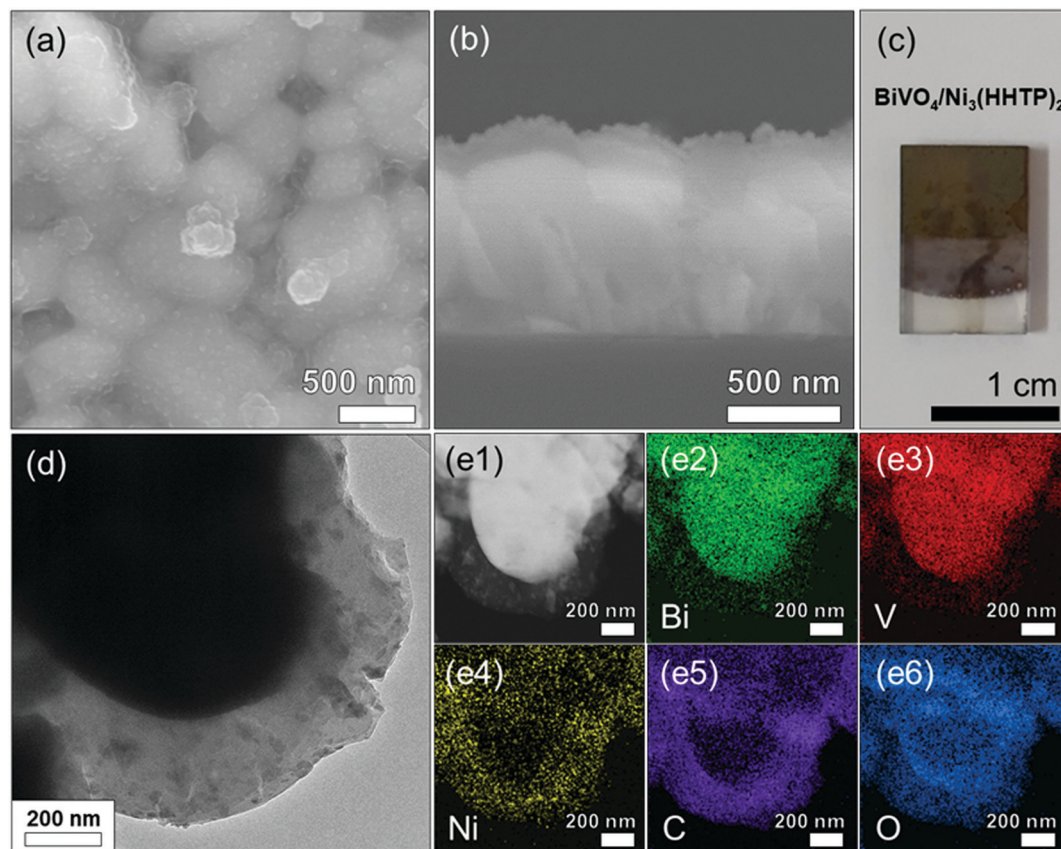


Fig. 2 (a) Top-view and (b) cross-sectional view of the SEM image of BiVO₄/Ni₃(HHTP)₂ heterostructure (solvothermal reaction for 3.5 h). (c) Photograph of BiVO₄/Ni₃(HHTP)₂ heterostructure photoanode. (d) TEM image and (e1–6) elemental mappings of BiVO₄/Ni₃(HHTP)₂ heterostructure.



The photocurrent densities of BiVO_4 and $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ were evaluated in both 0.1 M Na_2SO_3 and 0.1 M Na_2SO_4 solution under front and back illumination (Fig. 3a). In BiVO_4 photoanodes with sluggish charge transport kinetics, backside illumination led to a higher photocurrent density than frontside illumination because it allows the more efficient collection of photogenerated electrons.^{23,24} In the present study, hole-scavenging Na_2SO_3 was used to suppress the surface recombination of BiVO_4 .²⁵ At the potential of 1.23 V vs. RHE, BiVO_4 under front and back illumination showed photocurrent densities of 1.09 mA cm^{-2} and 1.42 mA cm^{-2} , respectively. When $\text{Ni}_3(\text{HHTP})_2$ was solvothermally coated onto BiVO_4 for 3.5 h, the photocurrent density significantly increased to 3.45 and 4.66 mA cm^{-2} under front and back illumination, respectively, which is approximately 3.2 times higher than that of a pristine BiVO_4 photoanode. When the solvothermal reaction time reached 6 h, however, the photocurrent density of $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ significantly decreased, probably because of ineffective charge transport through the extremely thick MOF layer (Fig. S8, ESI[†]). The photocurrent density of $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ reached 3.10 mA cm^{-2} at 1.23 V vs. RHE in 0.1 M Na_2SO_4 electrolyte (without hole-scavenging Na_2SO_3), suggesting that $\text{Ni}_3(\text{HHTP})_2$ is also a promising catalyst for photoelectrochemical water splitting (Fig. S9, ESI[†]). It is worth noting that the photocurrent density of the $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ photoanode is

similar to or greater than that of previous BiVO_4 -based hetero-junction photoanodes in the literature (Table S1, ESI[†]). Besides, $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ showed an abrupt slope change above 1.1 V vs. RHE with or without the presence of Na_2SO_3 . The J - V curves shown in Fig. S10 (ESI[†]) revealed that the current density of BiVO_4 did not significantly increase in the dark, while $\text{Ni}_3(\text{HHTP})_2$ and $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ have a different increasing trend above 1.1 V vs. RHE. Therefore, the unusual increasing trend could be attributed to an intrinsic catalytic activity of $\text{Ni}_3(\text{HHTP})_2$. The light on/off cycles of BiVO_4 and $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ were obtained by applying the constant potential of 1.23 V vs. RHE (Fig. 3b). Both photoanodes exhibited rapid photoresponses under initial illumination, followed by a stable steady-state, and were highly reproducible for a few cycles. The incident photon-to-electron conversion efficiency (IPCE) spectra were examined from 300 to 800 nm at 1.23 V vs. RHE to investigate the light absorption and energy conversion efficiency of BiVO_4 and $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ (Fig. 3c). $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ reached the highest IPCE of 83.4% at $\lambda = 460$ nm, which is almost four times higher than that of pristine BiVO_4 . The IPCE value significantly increased throughout the entire range, indicating that $\text{Ni}_3(\text{HHTP})_2$ promoted the effective utilization of visible light. Electrochemical impedance spectroscopy (EIS) of BiVO_4 and $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ was conducted at 1.23 V vs. RHE to examine the surface resistance and charge transport

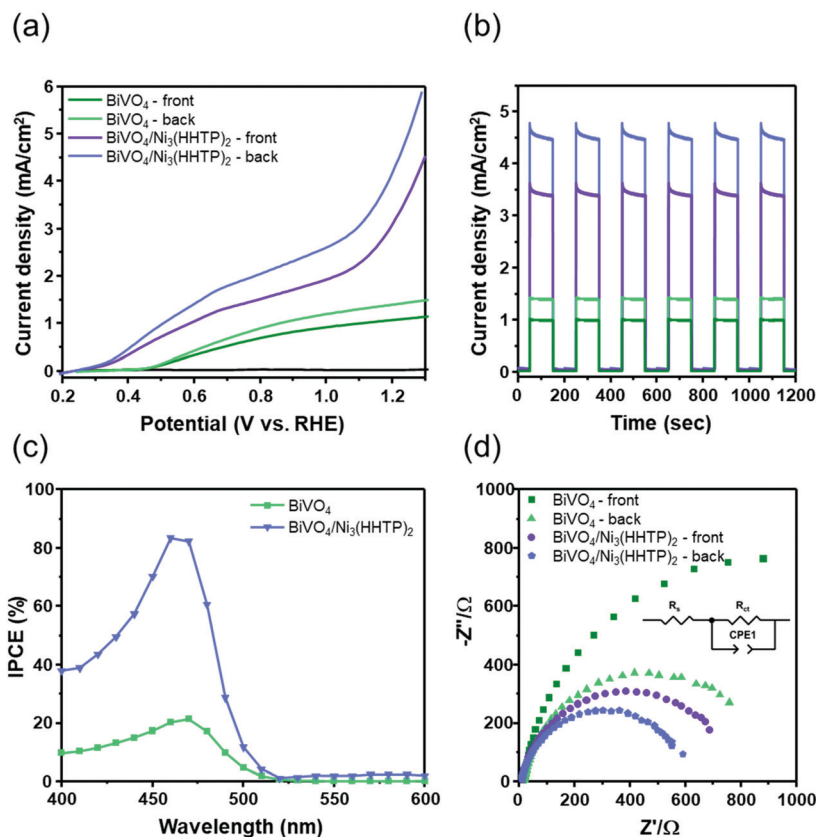


Fig. 3 (a) J - V curves of BiVO_4 and $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ (front and back illumination) in a 0.1 M Na_2SO_3 electrolyte. (b) Light on/off current density transients of BiVO_4 and $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ (front and back illumination) at 1.23 V vs. RHE. (c) IPCE measurements of BiVO_4 and $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$. (d) EIS analysis for BiVO_4 and $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ (front and back illumination).



Table 1 Fitted charge transfer resistance

Photoanode	R_s (Ω cm ²)	R_{ct} (Ω cm ²)
BiVO ₄ (front)	17.3	1740
BiVO ₄ (back)	17.7	909.5
BiVO ₄ /Ni ₃ (HHTP) ₂ (front)	8.5	665.3
BiVO ₄ /Ni ₃ (HHTP) ₂ (back)	7.4	447.9

during photoelectrochemical reactions (Fig. 3d). The obtained Nyquist plots were fitted and simulated to determine the R_{ct} values (charge transfer resistance at the interface between the photoanode and electrolyte) listed in Table 1. An equivalent circuit for the EIS results is shown in the inset of Fig. 3d. According to the fitted charge transfer resistance, back-illuminated BiVO₄ and BiVO₄/Ni₃(HHTP)₂ exhibited lower resistance than front-illuminated photoanodes. The results indicate that backside illumination is advantageous for collecting photogenerated electrons and can overcome the sluggish charge transport kinetics of BiVO₄. Moreover, additional EIS measurements (Fig. S11a, ESI[†]) were conducted in the dark at 0 V to confirm a junction formed between BiVO₄ and Ni₃(HHTP)₂. Without any external bias and light energy, the EIS spectra of BiVO₄ revealed one semicircle, while BiVO₄/Ni₃(HHTP)₂ revealed two semicircles. When Ni₃(HHTP)₂ formed a junction with BiVO₄, the R_{ct} values decreased from 909.5 Ω cm² to 447.9 Ω cm², indicating a facilitated charge transfer through the BiVO₄/Ni₃(HHTP)₂ and electrolyte interface. In addition, the charge carrier concentration (N_D) was calculated using Mott–Schottky analysis (Fig. S11b, ESI[†]). According to the Mott–Schottky plot, N_D can be calculated using the following equation:²⁶

$$N_D = \frac{2}{e\epsilon_0\epsilon} \times \left[\frac{d \left[\frac{1}{C^2} \right]}{dV_s} \right]^{-1}, \quad (1)$$

where e is the electronic charge (1.6×10^{-19} C), ϵ_0 is the vacuum permittivity (8.854×10^{-12} F m⁻¹), ϵ is the relative permittivity of BiVO₄ (68),²⁷ C (F cm⁻²) is the space charge capacitance, and V_s (V) is the applied potential. The obtained N_D values for BiVO₄ and BiVO₄/Ni₃(HHTP)₂ were 1.86×10^{16} cm⁻³ and 3.03×10^{16} cm⁻³, respectively. The results indicated that higher charge carrier concentration is generated through the heterojunction formed between BiVO₄ and Ni₃(HHTP)₂, implying that Ni₃(HHTP)₂ was highly effective at promoting charge carrier transport.

Co₃(HHTP)₂ and Cu₃(HHTP)₂ are two other potential conductive MOFs²⁸ that were coated onto BiVO₄ by a solvothermal reaction to investigate their photoelectrochemical performance. Upon their use, the photocurrent density increased to 2.25 and 1.77 mA cm⁻² (Fig. S12a, ESI[†]). The IPCE values of BiVO₄/Co₃(HHTP)₂ and BiVO₄/Cu₃(HHTP)₂ were more than twice that of with pristine (Fig. S12b, ESI[†]). The fitted R_{ct} values decreased as Co₃(HHTP)₂ and Cu₃(HHTP)₂ were coated onto BiVO₄ (Fig. S12c, d and Table S2, ESI[†]). The results confirm that the formation of a heterostructure photoanode between

semiconducting HHTP-based MOFs and BiVO₄ could enhance photoelectrochemical reactions.^{29–33} Although Co₃(HHTP)₂ and Cu₃(HHTP)₂ improved the photoelectrochemical activity of BiVO₄, its efficiency was lower than that of BiVO₄/Ni₃(HHTP)₂. The higher electrochemical performance of Ni₃(HHTP)₂ can be understood in terms of its high electrical conductivity among the three HHTP-based MOFs. To examine this, porous M₃(HHTP)₂ pellets were prepared (Fig. S13a, ESI[†]), and their electrical conductivities were measured using the two-electrode method. The conductivities are $\sigma = 4.45 \times 10^{-6}$ S cm⁻¹, 1.59×10^{-7} S cm⁻¹, and 4.29×10^{-8} S cm⁻¹ for Ni₃(HHTP)₂, Co₃(HHTP)₂, and Cu₃(HHTP)₂, respectively (Fig. S13b, ESI[†]). The conductivity of Ni₃(HHTP)₂ is significantly higher than those of Co₃(HHTP)₂ and Cu₃(HHTP)₂, even considering the small variation in densities, which is in line with the reported results.¹⁷ For M₃(HHTP)₂, the electrical conductivity is dependent on the type of metal ion with different electronic states.³⁴ Moreover, as M₃(HHTP)₂ frameworks are built in stacked two-dimensional (2D) structures, the interlayer spacing (S) along the c direction also influences the conduction. In general, a higher S value with a lower strength of interaction between the 2D layers yields a higher conductivity.³⁵ In the literature, Ni₃(HHTP)₂ was reported to have the highest S value (3.8 Å),³⁶ while Cu₃(HHTP)₂ had the lowest (3.16 Å) among the three MOFs.¹⁷ The conductivity values in the present study and literature suggest that the high conductivity of Ni₃(HHTP)₂ plays a key role in the superior photoelectrochemical performance of the BiVO₄/Ni₃(HHTP)₂ photoanode.

To reveal the dynamics of light absorption, charge separation, and charge transfer, the intrinsic band structures of BiVO₄ and Ni₃(HHTP)₂ were investigated using ultraviolet photoelectron spectroscopy (UPS) and ultraviolet-visible (UV-vis) spectroscopy. Fig. 4a and b show the UPS of BiVO₄ and Ni₃(HHTP)₂ for obtaining the work function (ϕ , energy from vacuum level to Fermi level) and valence band maximum (VBM, energy from Fermi level to valence band maximum). The work functions of BiVO₄ and Ni₃(HHTP)₂ are 4.20 eV and 5.0 eV, while the VBM values are 2.25 eV and 1.62 eV, respectively. The UV-vis spectra in Fig. 4c shows that the energy bandgaps of BiVO₄ and Ni₃(HHTP)₂ were 2.50 and 2.68 eV, respectively. The intrinsic band structures of BiVO₄ and Ni₃(HHTP)₂ are shown in Fig. 4d. As BiVO₄ has a higher E_F than Ni₃(HHTP)₂, the electrons would transfer from BiVO₄ to Ni₃(HHTP)₂ until equilibrium is reached. After the electronic state reached equilibrium, the band structure caused the upward band edge bending of BiVO₄, and downward band edge bending of Ni₃(HHTP)₂, forming a type-II heterojunction. In the type-II heterojunction established in BiVO₄/Ni₃(HHTP)₂, the photogenerated electrons migrated from the conduction band (E_C) of Ni₃(HHTP)₂ to the E_C of BiVO₄. In contrast, the photogenerated holes migrated from the valence band (E_V) of BiVO₄ to the E_V of Ni₃(HHTP)₂, facilitating the separation of photogenerated charge carriers (Fig. 4e). In addition, the intrinsic band structures of Co₃(HHTP)₂ and Cu₃(HHTP)₂ were investigated to understand the band-bending between BiVO₄/Co₃(HHTP)₂ and BiVO₄/Cu₃(HHTP)₂ (Fig. S14 and S15, ESI[†]). Both BiVO₄/Co₃(HHTP)₂ and BiVO₄/



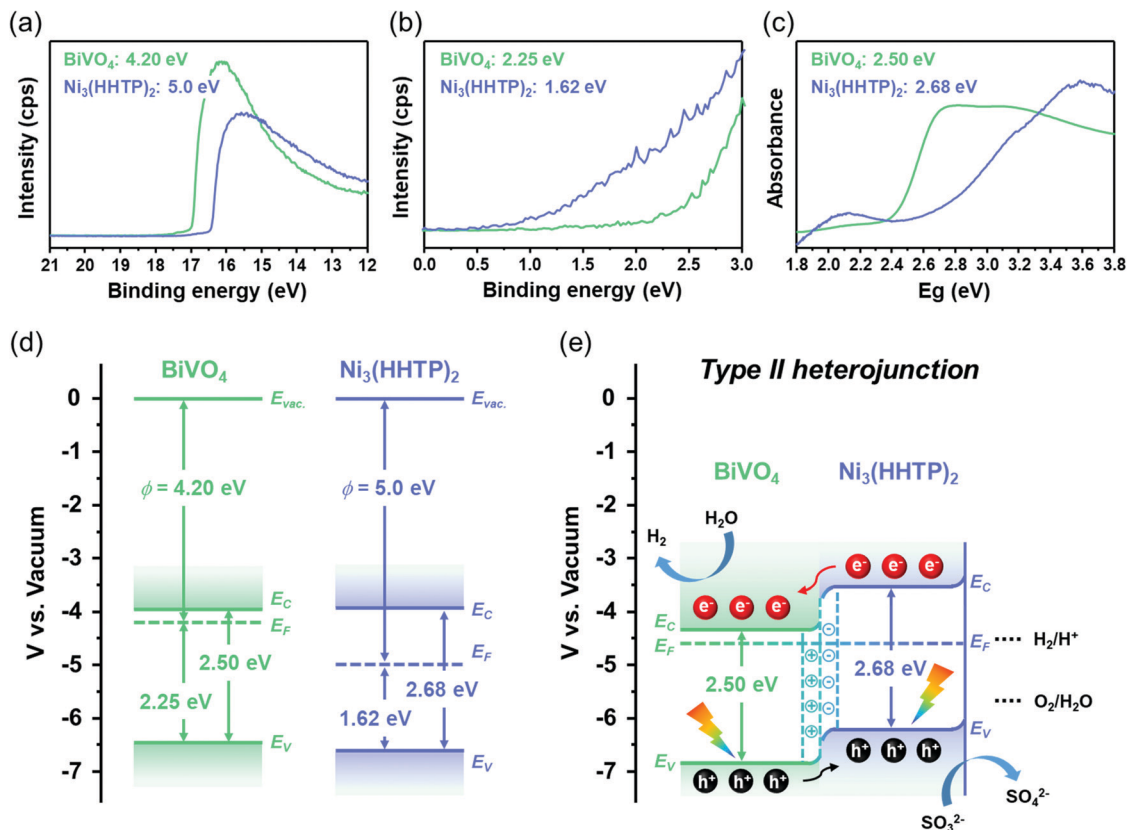


Fig. 4 UPS of BiVO_4 and $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ for obtaining (a) work function (ϕ) and (b) VBM. (c) UV-vis spectra of BiVO_4 and $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$. Schematic energy band diagram of BiVO_4 and $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ (d) before contact and (e) after contact.

$\text{Cu}_3(\text{HHTP})_2$ achieved the type-II heterojunction after reaching equilibrium. The band-bending structure is in line with the photoelectrochemical activities, indicating that the coating with HHTP-based MOFs promotes effective charge separation for the efficient photoelectrochemical performance of BiVO_4 . The results validate the high versatility of HHTP-based MOFs along with the enhanced photoelectrochemical activities of $\text{BiVO}_4/\text{HHTP}$ -based MOF heterostructure photoanodes.

Aside from band-bending diagrams of $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$, it is crucial to examine the three critical factors affecting the photoelectrochemical activity: light absorption efficiency (η_{abs}), charge separation efficiency (η_{sep}), and charge transfer efficiency (η_{trans}). The three factors are expressed in the following water oxidation equation:^{37–39}

$$J_{\text{water}} = J_{\text{max}} \times \eta_{\text{abs}} \times \eta_{\text{sep}} \times \eta_{\text{trans}} \quad (2)$$

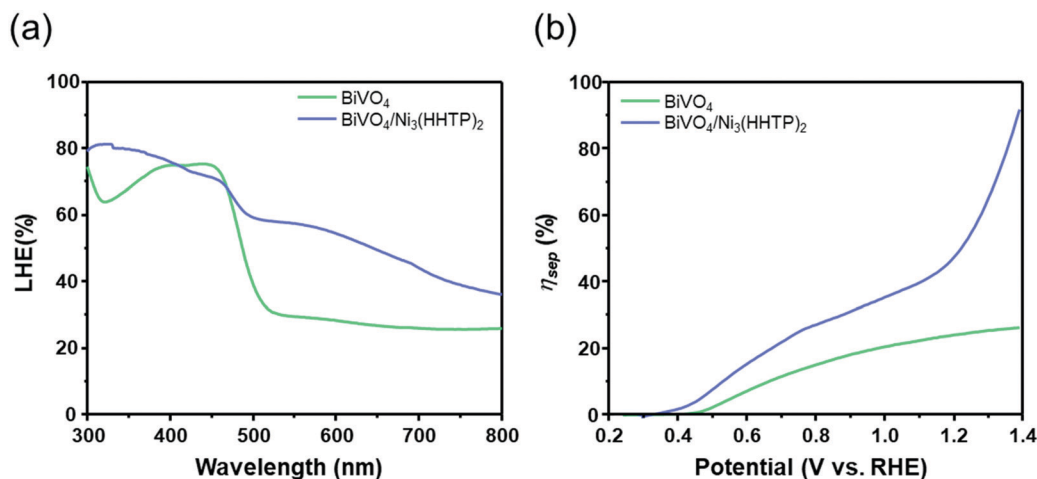


Fig. 5 (a) Light harvesting efficiency (LHE) (%) and (b) charge separation efficiency (η_{sep}) of BiVO_4 and $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$.



where J_{\max} is the theoretical maximum photocurrent density, and J_{water} is the experimentally obtained photocurrent density. To simplify the equation, η_{trans} can be assumed as 100% when the hole scavenger (Na_2SO_3) that induces rapid oxidation kinetics is present in the electrolyte.

$$J_{\text{sulfite}} = J_{\max} \times \eta_{\text{abs}} \times \eta_{\text{sep}} \quad (3)$$

If it is assumed that all the absorbed photons are fully converted to photocurrent density, the η_{sep} and η_{trans} can be neglected. The equation can be further simplified as follows:

$$J_{\text{abs}} = J_{\max} \times \eta_{\text{abs}} \quad (4)$$

Light absorption was observed at 496 nm and 504 nm for BiVO_4 and $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$, respectively (Fig. 5a). By integrating the electron flux of both air mass (AM) 1.5G and the photoanode, as shown in Fig. S16a and b (ESI[†]), the J_{\max} of BiVO_4 and $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ are 6.44 mA cm^{-2} and 6.95 mA cm^{-2} , while the J_{abs} are 4.42 mA cm^{-2} and 4.89 mA cm^{-2} , respectively (Table S3, ESI[†]). The η_{abs} of BiVO_4 and $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ were calculated as 68.6% and 70.4%, respectively. Although $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ yielded higher η_{abs} than BiVO_4 , the enhancement was not significant because $\text{Ni}_3(\text{HHTP})_2$ has a bandgap of 2.68 eV, which is slightly larger than that of BiVO_4 (2.50 eV). The $\eta_{\text{abs}} \times \eta_{\text{sep}}$ of BiVO_4 and $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ were obtained by eliminating the η_{trans} (Fig. S16c, ESI[†]). Consequently, with the known η_{abs} , the η_{sep} of the photoanodes was calculated, as shown in Fig. 5b. When $\text{Ni}_3(\text{HHTP})_2$ was coated onto BiVO_4 , the η_{sep} significantly increased to 51.4%, which is 2.1 times higher than that of pristine BiVO_4 film. These results show that establishing a type-II heterojunction between $\text{Ni}_3(\text{HHTP})_2$ and BiVO_4 promotes effective charge separation, which ultimately improves the photoelectrochemical performance of the photoanodes. The long-term stability of the BiVO_4 and $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ photoanodes was also examined for 40 000 s at 1.23 V vs. RHE (Fig. S17, ESI[†]). No severe degradation was observed, and the results indicate that $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ was electrochemically stable over a long period. In addition, the structure of $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ after photoelectrochemical reactions was observed by TEM and elemental mappings (Fig. S18, ESI[†]). The adhesion between BiVO_4 and $\text{Ni}_3(\text{HHTP})_2$ was strong enough to maintain its stable structure even after photoelectrochemical reactions.

Conclusions

$\text{BiVO}_4/\text{M}_3(\text{HHTP})_2$ heterojunction photoanodes with three different metal ions (M = Ni, Co, and Cu) were prepared *via* facile electrodeposition followed by a solvothermal process for photoelectrochemical reactions. The $\text{M}_3(\text{HHTP})_2$ coating is aimed at improving the sluggish charge transport kinetics of BiVO_4 by forming staggered band alignments. All three $\text{BiVO}_4/\text{M}_3(\text{HHTP})_2$ photoanodes exhibited higher photocurrent densities than the pristine BiVO_4 film; type-II heterojunctions were observed between BiVO_4 and $\text{M}_3(\text{HHTP})_2$. Effective light absorption and charge separation were achieved through the type-II

heterojunctions, which were confirmed by UPS and UV-vis spectroscopy. In particular, $\text{BiVO}_4/\text{Ni}_3(\text{HHTP})_2$ had the highest photocurrent density of 4.66 mA cm^{-2} , which is 3.2 times greater than that of pristine BiVO_4 . Among the three types of $\text{M}_3(\text{HHTP})_2$, $\text{Ni}_3(\text{HHTP})_2$ exhibited the highest bulk conductivity, indicating that the electrical conductivity of MOF and the type-II band alignment significantly influenced the photoelectrochemical performance. This study demonstrates that establishing a type-II heterojunction between semiconducting $\text{M}_3(\text{HHTP})_2$ and BiVO_4 is a promising and general strategy for obtaining high-performance photoanodes.

Conflicts of interest

There are no conflicts to declare.

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